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# Dicyanovinyl-substituted indolo[3,2-b]indole derivatives: low-band-gap $\pi$ -conjugated molecules for a single-component ambipolar organic field-effect transistor†

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A series of low-band-gap  $\pi$ -conjugated molecules comprising N,N'-dihexylindolo[3,2-b]indole as an electron donor (D) and dicyanovinyl as an electron acceptor (A) with  $A-\pi-D-\pi-A$  architecture have been designed and synthesized to fabricate a single-component ambipolar organic field-effect transistor (OFET). Molecules with different  $\pi$ -bridging units (none, thiophene, and bithiophene) were synthesized and characterized to investigate their structure-property correlation. *Via* the cooperative effects of intramolecular charge transfer (ICT) interactions and extension of conjugation, the band gap of the newly synthesized molecules was reduced to 1.41 eV in the solution state. Among other compounds, **2H2TIDID-DCV** (with a thiophene  $\pi$ -spacer) exhibited highly balanced ambipolar charge transport with hole and electron mobilities of 0.08 cm² V<sup>-1</sup> s<sup>-1</sup> and 0.09 cm² V<sup>-1</sup> s<sup>-1</sup>, respectively, from a vacuum-deposited OFET device. Spin-coated OFET devices using **OD2TIDID-DCV**, in which the hexyl side chains of **2H2TIDID-DCV** are replaced by 2-octyldodecyl groups, also exhibited an ambipolar charge-transporting nature (mobilities of 9.67 × 10<sup>-2</sup> cm² V<sup>-1</sup> s<sup>-1</sup> for holes and 3.43 × 10<sup>-3</sup> cm² V<sup>-1</sup> s<sup>-1</sup> for electrons). Both **2H2TIDID-DCV** and **OD2TIDID-DCV** exhibited favorable thin-film morphology for the formation of charge-transporting channels, and structural analyses of these films revealed the same molecular packing characteristics of a three-dimensional lamellar  $\pi$ -stacking structure.

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#### Introduction

Research interest in ambipolar organic field-effect transistors (OFETs) has grown significantly because of their potential application to complementary circuits such as inverters without a complicated multi-step deposition process. <sup>1,2</sup> In particular, single-component ambipolar OFETs that simply comprise a single-layer active channel with symmetric source-drain electrodes have attracted much attention owing to their expediency in the practical fabrication of devices. <sup>2-4</sup> In theory, many organic semiconductors are known to transport both types of charge carrier in their solid state if and only if the charge carriers are efficiently injected. <sup>2,5</sup> However, the majority of reported organic semiconductors exhibited unipolar characteristics, *i.e.*, either holes or electrons were transported only, depending on the work

function of the electrodes, which was mainly due to the restriction of a high injection barrier for one of the carriers. 6-8 Therefore, among various crucial issues in fabricating single-component ambipolar OFETs, a balanced alignment of the energy levels of the highest occupied molecular orbital (HOMO) and lowest unoccupied molecular orbital (LUMO) of the organic semiconductor relative to the work function of the symmetric electrode is essential for favorable bipolar injection.<sup>2,8-11</sup> In this regard, a wide range of low-band-gap organic materials has been extensively investigated and some π-conjugated structures such as TIPS-pentacenes, 12-14 diketopyrrolopyrroles, 15-18 indigos, 19 isoindigos, 20 and quinoidal oligothiophenes21-23 have been reported as promising backbone structures for designing high-performance ambipolar semiconductors via appropriate engineering of the molecular structure.24 In spite of extensive materials research into ambipolar OSCs, the effect of molecular structure on the operating mechanism of ambipolar OFETs has seldom been studied. In this regard, the investigation of structure-property correlations based on comprehensive photophysical, electrochemical, and quantum chemical calculation studies is essential for developing high-performance organic semiconductors.

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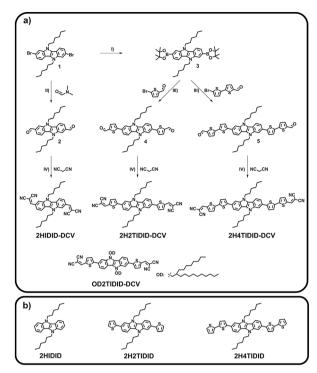
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Very recently, we have synthesized indolo[3,2-b]indole (IDID) derivatives as promising p-type organic semiconductors with a remarkable hole mobility of 0.97 cm<sup>2</sup> V<sup>-1</sup> s<sup>-1</sup> and versatile processability.<sup>25</sup> Besides the apparent advantages of a pyrrolefused structure such as facile control of solubility and structural derivatization, the IDID core is characterized by a stronger electron-donating nature than those of other reported pyrrolefused heteroarene cores (e.g., carbazole and indolocarbazole) owing to the larger proportion of five-membered pyrrole units in the backbone. To examine the possible bipolar injection and transport of carriers, we here designed and synthesized intramolecular charge transfer (ICT)-type IDID derivatives (IDID-DCV derivatives), namely, 2HIDID-DCV, 2H2TIDID-DCV, and 2H4TIDID-DCV, which comprise IDID as an electron donor (D) and dicyanovinyl (DCV) as an electron acceptor (A) with  $A-\pi-D-\pi-A$ -type architecture. Three different  $\pi$ -linking units (none, thiophene, and bithiophene) were incorporated to study different degrees of ICT interaction and  $\pi$ -conjugation, which enabled both a molecular structure-property correlation and the precise control of electronic characteristics. For an elaborate in-depth analysis of structure-property correlations we also prepared p-type reference molecules, namely, 2HIDID, 2H2TIDID, and 2H4TIDID, on which comprehensive studies were conducted in terms of their theoretical, photophysical, electrochemical, morphological, electrical, and structural characteristics. Among other compounds, **2H2TIDID-DCV** (with a thiophene  $\pi$ -linker) exhibited a dramatically reduced energy band gap (1.62 eV in the solution state), as well as excellent film morphology, which afforded highly balanced ambipolar charge transport with hole and electron mobilities of 0.08 cm<sup>2</sup> V<sup>-1</sup> s<sup>-1</sup> and 0.09 cm<sup>2</sup> V<sup>-1</sup> s<sup>-1</sup>, respectively, in vacuum-deposited (VD) OFET devices. With the aim of fabricating a solution-processable IDID-DCV derivative, OD2TIDID-DCV was also synthesized, in which the hexyl side chains of 2H2TIDID-DCV were replaced by 2-octyldodecyl groups. A spin-coated OFET device using OD2TIDID-DCV also exhibited ambipolar charge transport behavior (mobilities of 9.67  $\times$  $10^{-2}~\text{cm}^2~\text{V}^{-1}~\text{s}^{-1}$  for holes and 3.43 imes  $10^{-3}~\text{cm}^2~\text{V}^{-1}~\text{s}^{-1}$  for electrons). To the best of our knowledge, this is the first report of a single-component ambipolar OFET based on a pyrrolefused heteroacene family, even including the widely studied indolocarbazole derivatives.

## Result and discussion

To understand the effects of ICT interactions and alterations in the molecular structure on the electronic characteristics of IDID derivatives, and also to fabricate an ambipolar OSC for practical applications, we rationally designed a molecular structure as follows. Using the DCV unit as a strong electron acceptor, we constructed an A- $\pi$ -D- $\pi$ -A-type molecular architecture not only to exhibit strong ICT interactions but also to enable efficient electron injection by lowering the LUMO energy level, 26,27 for which purpose the electronic and intramolecular interaction characteristics were delicately tuned by altering the  $\pi$ -linker (none, thiophene, or bithiophene). Based on this idea,



Scheme 1 (a) Synthetic routes to IDID-DCV derivatives and their chemical structures: (I) bis(pinacolato)diborane, Pd<sub>2</sub>(dppf)<sub>2</sub>, KOAc, anhydrous dimethylformamide, (II) n-BuLi, tetrahydrofuran, (III) Pd(PPh<sub>3</sub>)<sub>4</sub>, 2 N K<sub>2</sub>CO<sub>3</sub>, tetrahydrofuran, (IV) Al<sub>2</sub>O<sub>3</sub>, methylene chloride; (b) chemical structure of IDID reference derivatives

we designed a series of three IDID-DCV derivatives, namely, 2HIDID-DCV, 2H2TIDID-DCV, and 2H4TIDID-DCV (Scheme 1). The synthesis of 2,7-dibromo-*N*,*N*′-dihexyl-IDID (compound 1) was performed according to our previous report,25 from which IDID-DCV derivatives were successfully synthesized via lithiumexchange formylation, palladium-catalyzed borylation, Suzuki-Miyaura cross-coupling, and the Knoevenagel condensation reaction. All three target compounds were carefully characterized by <sup>1</sup>H NMR, <sup>13</sup>C NMR, elemental analysis, and mass analysis. The detailed synthetic procedures are described in Scheme 1 and the Experimental section.

For a comprehensive understanding of the newly synthesized IDID-DCV derivatives in terms of their photophysical properties, we also prepared three IDID reference materials, namely, 2HIDID, 2H2TIDID, and 2H4TIDID, which have exactly the same molecular structures as those of 2HIDID-DCV, 2H2TIDID-DCV, and 2H4TIDID-DCV, respectively, but without the acceptor unit (DCV) (see Scheme 1. 2H2TIDID and 2H4TIDID were reported earlier, 25 but **2HIDID** was newly synthesized in this work. The detailed synthetic procedure and characterization of 2HIDID are described in the ESI†).

The electronic characteristics of the IDID-DCV derivatives were determined via molecular orbital calculations, UV-vis spectroscopy, and cyclic voltammetry (CV) measurements. The ground-state optimized geometries and electronic structures of the IDID derivatives were calculated within the density functional theory (DFT) by the B3LYP method using the Gaussian 09

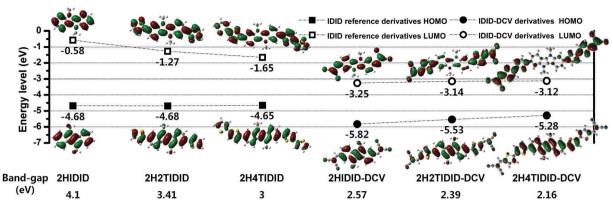


Fig. 1 Plot of calculated energy levels for IDID-DCV derivatives and IDID reference derivatives and their molecular orbital contours (DFT/B3LYP/6-31G(d,p): the alkyl chains were replaced by methyl groups in the calculations)

package with the 6-31G(d,p) basis set. According to the calculated energies of the frontier orbitals shown in Fig. 1, it is noted that the effect of different  $\pi$ -linking units (none, thiophene, or bithiophene) in the IDID-DCV derivatives is quite different from that in the p-type IDID reference derivatives. Because the IDID unit intrinsically has a very low ionization potential, the extension of  $\pi$ -conjugation with thiophene units mostly resulted in stabilization of the LUMO energies with no variation in the HOMO in the case of the p-type reference derivatives. Although both the HOMO and LUMO energies of a given IDID-DCV derivative were strongly stabilized in comparison with those of the respective IDID reference derivative, the actual degree of stabilization increased in the order of the different  $\pi$ -linking units (none > thiophene > bithiophene), as seen in Fig. 1. This can be rationally correlated with the increasing strength of ICT characteristics with a decrease in the D-A distance.

For the empirical study of electronic transitions, the UV-vis absorption spectra of the IDID derivatives were recorded at a concentration of  $1 \times 10^{-5}$  M in solution in tetrahydrofuran (THF) and also for spin-coated films (see Fig. 2; the detailed data are listed in Table 1). In the solution state, all the IDID-DCV derivatives exhibited broad absorption bands consisting of three absorption maxima. Interestingly, the locations of the maxima for the lowest-energy transition corresponding to the ICT transition were virtually the same for all of them (544 nm for 2HIDID-DCV and 555 nm for 2H2TIDID-DCV and 2H4TIDID-DCV), in spite of the lengths of the  $\pi$ -linker being different from each other. This feature can be understood by comparing their absorption spectra with those of the reference derivatives. As shown in Fig. 2c, the IDID-DCV derivatives exhibited different degrees of bathochromic shift in their absorption spectra ( $\triangle \lambda_{\text{max}}$ s, see Table 1), which increased with a decrease in the D-A distance. The fact that the ICT absorption wavelengths among the IDID-DCV derivatives were apparently similar can thus be rationalized on the basis of a reduction in the strength of ICT and the effects of conjugation length. The strength of ICT interactions between IDID and DCV became less for molecules with a larger number of thiophene  $\pi$ -spacers, which at the same time was compensated for by an increase in the length of  $\pi$ -conjugation to give a comparable absorption maximum wavelength. For solid-state samples of the

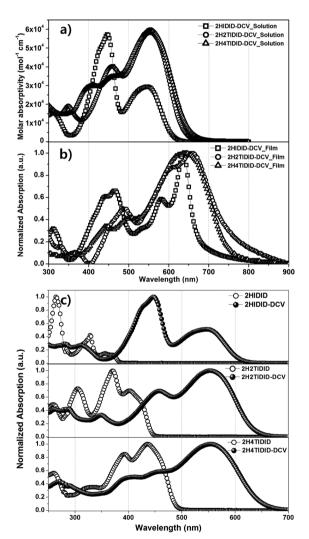


Fig. 2 Absorption spectra of IDID-DCV derivatives in the solution state (a) and film state (b) and each solution-state absorption spectrum with that of the corresponding reference derivative (c).

IDID-DCV derivatives, further bathochromic shifts of 90-100 nm with distinct vibronic features were observed, as shown in Fig. 2b and summarized in Table 1.

1.41/1.25

2H4TIDID-DCV

Abs.  $\lambda_{\text{max}}^{a}$  $\triangle \lambda_{max}$ s  $HOMO^{c}$  $LUMO^{c}$ Band gap<sup>d</sup> [sol./film/ $\triangle \lambda_{max}$ , nm] Compound  $[nm]^b$ [sol./film, eV] [sol./film, eV] [sol./film, eV] 544/636/89 2HIDID-DCV 179 -5.34/-5.42-3.51/-3.711.81/1.71 2H2TIDID-DCV 555/657/103 151 -5.08/-5.09-3.46/-3.861.62/1.23

118

Table 1 Optical and electrochemical properties of IDID-DCV derivatives

555/641/89

-4.90/-4.99

To investigate the electrochemical properties of the IDID-DCV derivatives, cyclic voltammetry (CV) measurements were made both in the solution state and the solid (film) state. The energies of the HOMO, LUMO, and electrochemical band gap, which were deduced from the first oxidation onset and the first reduction onset of the CV curves, are listed in Table 1. As shown in Fig. 3, the IDID-DCV derivatives exhibited quasireversible multi-stage electrochemical oxidation and reduction behavior in a THF solvent. In agreement with the results of DFT calculations in Fig. 1, the LUMO energies of the IDID-DCV derivatives were strongly stabilized and located at similar levels (around -3.5 eV), as seen in Fig. 3 and Table 1. Moreover, the HOMO energies were gradually destabilized with an increase in the length of the  $\pi$ -spacer, *i.e.*, -5.34, -5.08, and -4.90 eV. In consequence, we could achieve quite small band gaps (i.e., down to 1.41 eV) using the compensated ICT interactions

2HIDID-DCV\_sol. 4x10<sup>-6</sup> 2H2TIDID-DCV\_sol 2H4TIDID-DCV\_sol 2x10 Current (A) -4x10 -6x10 Potential (V) 4x10 2HIDID-DCV\_film b) 2H2TIDID-DCV file 3x10 2H4TIDID-DC\ 2x10 Current (A) -1x10 0.6 0.8 Potential (V)

Fig. 3 Cyclic voltammograms of IDID-DCV derivatives in the solution state (a) and film state (b) (insets: ferrocene).

between IDID and DCV. In the case of the film state, the HOMO and LUMO energies of the IDID-DCV derivatives were even further stabilized, with the degree of stabilization for the LUMO energies higher than that for the HOMO energies to give smaller band gap energies. Interestingly, the largest stabilization of the LUMO in the solid state, which gave the smallest band gap energy of 1.23 eV, was observed for 2H2TIDID-DCV (see Table 1), which confirms that the electronic interaction was strongest and most efficient in the tightly packed solid state, which suggests excellent OFET mobility (see below).

-3.49/-3.74

Based on their photophysical and electrochemical properties (i.e., a satisfactorily low band gap with suitable HOMO and LUMO energies in the solid state for efficient bipolar injection from symmetric source-drain electrodes), two of the IDID-DCV derivatives, namely, 2H2TIDID-DCV and 2H4TIDID-DCV, were selected for the evaluation of their OFET characteristics. Before the fabrication of the OFET device, however, we examined the surface topography of VD thin films as a function of alterations in the substrate temperature ( $T_{\text{sub}}$ ). As shown in Fig. S1 (ESI†), 2H2TIDID-DCV films exhibited dense and compact grain features that were suitable for OFET fabrication, whereas 2H4TIDID-DCV VD films displayed coarse and undefined topological characteristics that were unsuitable for device construction. Therefore, the charge transport characteristics of 2H2TIDID-DCV were evaluated for ambipolar mobility in the geometry of bottom-gate top-contact (BGTC) VD OFET devices. 2H2TIDID-DCV was thermally evaporated and deposited on SiO<sub>2</sub>/Si substrates treated with octadecyltrichlorosilane (ODTS) at different  $T_{\rm sub}$  values from room temperature (RT) to 140  $^{\circ}{\rm C}$ to optimize the device performance. As previously reported, OFET devices using 2H2TIDID exhibited typical p-type OFET behavior.<sup>25</sup> In contrast, OFET devices using 2H2TIDID-DCV displayed ambipolar OFET behaviour, exhibiting typical V-shaped transfer curves and unique output curves with a superlinear regime, as seen in Fig. 4a to f. With an increase in  $T_{\text{sub}}$ , the hole and electron mobilities increased simultaneously (see Fig. S2 and Table 2, ESI†).

In particular, the electron mobility was much more dramatically increased by altering the deposition temperature (an increase of nearly four orders of magnitude, from  $1.5 \times 10^{-5}$  to  $9.2 \times 10^{-2}$  cm<sup>2</sup> V<sup>-1</sup> s<sup>-1</sup>) than was the hole mobility (from  $1.8 \times 10^{-3}$  to  $8.2 \times 10^{-2}$  cm<sup>2</sup> V<sup>-1</sup> s<sup>-1</sup>), and the devices that were deposited at a high  $T_{\rm sub}$  (>70 °C), exhibited well-balanced hole

 $<sup>^</sup>a$   $\lambda_{\rm max}$  is derived from the maximum for the lowest spin-allowed transition.  $\triangle\lambda_{\rm max}$  represents the difference in  $\lambda_{\rm max}$  between the solution state and film state. The absorption spectra of solutions were recorded in THF (at a concentration of  $1\times 10^{-5}$  M), and the absorption spectra of films were recorded with a spin-coated sample (1500 rpm/60 s, 0.3 wt% in chloroform).  $^b$   $\triangle\lambda_{\rm max}$ s represents the absolute difference in  $\lambda_{\rm max}$  between the IDID-DCV derivative and the corresponding IDID reference in the solution state.  $^c$  HOMO and LUMO energy levels were determined by cyclic voltammetry. Solution samples were prepared at  $3\times 10^{-3}$  M in THF and film samples were prepared on ITO patterned glass by drop-casting.  $^d$  Band gap =  $V_{\rm oxidation} - V_{\rm reduction}$ .

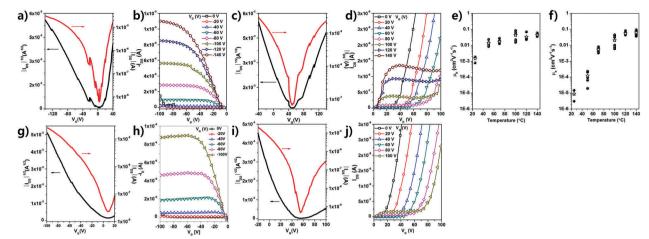


Fig. 4 OFET device characteristics. (a to f) Representative OFET device characteristics of **2H2TIDID-DCV**: (a and c) transfer curves of device formed at a  $T_{\text{sub}}$  of 120 °C, (b and d) output curves of device formed at a  $T_{\text{sub}}$  of 120 °C, and (e and f) temperature-dependent mobility for p- and n-channel operation, respectively (the white stars represent average values). (g to j) Characteristics of spin-coated OFET device using **OD2TIDID-DCV** (annealing temperature is 150 °C): (g and i) transfer curves and (h and j) output curves for p- and n-channel operation, respectively.

Table 2 OFET device characteristics

		p-Channel operation			n-Channel operation			
Compound	$T_{\mathrm{sub}}^{a} \left[ {}^{\circ}\mathrm{C} \right]$	$\mu_{\rm h}$ , max/average <sup>b</sup> [cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> ]	$V_{ m th}  [{ m V}]^c$	$I_{ m on}/I_{ m off}$	$\mu_{\rm e}$ , max/average <sup>b</sup> [cm <sup>2</sup> V <sup>-1</sup> s <sup>-1</sup> ]	$V_{ m th}{}^c \left[ { m V}  ight]$	$I_{ m on}/I_{ m off}$	p/n ratio
2H2TIDID-DCV	RT 50 70 100 120 140	$\begin{array}{c} 1.85 \times 10^{-3} / 1.43 \times 10^{-3} \\ 2.30 \times 10^{-2} / 1.39 \times 10^{-2} \\ 2.76 \times 10^{-2} / 1.69 \times 10^{-2} \\ 8.28 \times 10^{-2} / 4.30 \times 10^{-2} \\ 6.86 \times 10^{-2} / 3.30 \times 10^{-2} \\ 5.89 \times 10^{-2} / 4.41 \times 10^{-2} \end{array}$	-42 (±8) -22 (±12) -9 (±9) -7 (±3) -13 (±4) -15 (±3)	$ 3 \times 10^{4}  1 \times 10^{5}  4 \times 10^{4}  1 \times 10^{3}  4 \times 10^{3}  1 \times 10^{4} $	$\begin{array}{c} 1.47 \times 10^{-5} / 8.79 \times 10^{-6} \\ 2.32 \times 10^{-4} / 1.23 \times 10^{-4} \\ 8.07 \times 10^{-3} / 5.39 \times 10^{-3} \\ 4.46 \times 10^{-2} / 2.09 \times 10^{-2} \\ 8.13 \times 10^{-2} / 5.45 \times 10^{-2} \\ 9.24 \times 10^{-2} / 6.21 \times 10^{-2} \end{array}$	60 (±5) 100 (±10) 67 (±18) 61 (±10) 61 (±13) 77 (±9)	$2 \times 10^{1} \\ 3 \times 10^{2} \\ 3 \times 10^{3} \\ 5 \times 10^{2} \\ 9 \times 10^{2} \\ 3 \times 10^{3}$	125.85 99.14 3.42 1.86 0.84 0.63
$\mathbf{2H2TIDID}^{e}$	70	$3.20 \times 10^{-2} / 3.00 \times 10^{-2}$	$-11~(\pm 2)$	$1\times 10^4$	_	_	_	_
OD2TIDID-DCV	$150^d$	$9.67 \times 10^{-2} / 5.28 \times 10^{-2}$	$-24\ (\pm 9)$	$4 \times 10^4$	$3.42 \times 10^{-3} / 1.25 \times 10^{-3}$	50 (±11)	$1 \times 10^2$	28.27

<sup>&</sup>lt;sup>a</sup> Substrate temperature in vacuum deposition. <sup>b</sup> The mobilities were derived from the saturation regimes. <sup>c</sup> Average threshold voltages. The values in parentheses represent one standard deviation. <sup>d</sup> Post annealing temperature of spin-coated device ( $^{\circ}$ C). <sup>e</sup> From ref. 25.

and electron mobilities (the ratio of hole mobility to electron mobility was 0.63 at a  $T_{\rm sub}$  of 140 °C). Such different tendencies of the variations in electron and hole mobility are most probably due to the sensitivity to trap sites of electron charge carriers being higher than that of hole charge carriers.28 The increase in mobility could be attributed to the reduced density of trap sites originating from an increase in grain size, as was rationalized from a study of surface topography using atomic force microscopy (AFM) measurements. As shown in Fig. 5a to f, the surface topography of 2H2TIDID-DCV film was transformed from a uniform film (root-mean-square roughness value of 0.7 nm) into a highly ordered crystalline film with terrace-structured grains with an increase in  $T_{\text{sub}}$ ; structured grains developed from a  $T_{\text{sub}}$  of 70 °C, and micron-sized grains were observed from a  $T_{\rm sub}$ of 120 °C. By correlating charge carrier mobility with surface topography, it was found that the terrace-structured and enlarged grains were responsible for the favorable intermolecular packing structure for the transport of both hole and electron charge carriers (see below).

To demonstrate a solution-processable IDID-DCV derivative, we additionally synthesized OD2TIDID-DCV, in which the linear hexyl side chains in 2H2TIDID-DCV were replaced by branched 2-octyldodecyl groups (see Scheme 1 and Scheme S2; detailed synthetic procedures and characterizations are described in the ESI†). Spin-coated OFET devices using OD2TIDID-DCV were fabricated and characterized for the same OFET structure and geometry as the VD devices, but with the semiconducting material (OD2TIDID-DCV) deposited by a spin-coating method. As shown in Fig. 4g to j, the optimized spin-coated OFET device (post annealing temperature of 150 °C) exhibited ambipolar charge transport behaviour, with hole and electron mobilities of  $9.6 \times 10^{-2} \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1} \text{ and } 3.4 \times 10^{-3} \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}, \text{ respec-}$ tively. With respect to the values of charge carrier mobility, solution-processed devices using OD2TIDID-DCV exhibited slightly higher values of hole mobility but relatively lower values of electron mobility than those of 2H2TIDID-DCV. Such different values of mobility were due to the somewhat different  $\pi$ - $\pi$  distances (see below) and rather smaller grain sizes in comparison with those of the optimized VD device (see Fig. 5g).

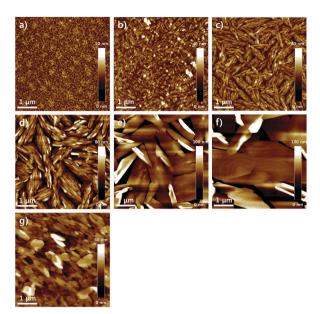


Fig. 5 AFM surface topologies (height images, 5  $\mu m$   $\times$  5  $\mu m$ ) of **2H2TIDID-DCV** VD thin films formed at different values of  $T_{\text{sub}}$ : (a) RT; (b) 50 °C; (c) 70 °C; (d) 100 °C; (e) 120 °C; (f) 140 °C, and **OD2TIDID-DCV** spin-coated film (g) annealed at 150 °C

In any case, the experimentally confirmed ambipolarity in the devices using 2H2TIDID-DCV and OD2TIDID-DCV suggests that 2TIDID-DCV is a promising  $\pi$ -conjugated backbone for single-component ambipolar OFETs.

To investigate the molecular packing structure in the organic semiconductor samples, analyses by out-of-plane X-ray diffraction (XRD), powder XRD, and 2D grazing incidence X-ray diffraction (2D-GIXD) were carried out. Fig. 6a shows the out-of-plane XRD patterns of 2H2TIDID-DCV thin films.

Whereas samples formed at a low  $T_{\text{sub}}$  (RT and 50 °C) exhibited quite weak diffraction peaks, samples that were deposited at a high T<sub>sub</sub> (over 70 °C) exhibited sharp and strong diffraction peaks up to the third (300) order at 2 theta values of 8.37°, 16.78°, and 25.28°; this could be interpreted as lamellar diffraction with a d-spacing of 10.58 Å. From the powder XRD pattern (Fig. 6b), identical lamellar diffraction peaks to those of out-of-plane XRD could be observed at almost the same 2 theta values (8.36°, 16.67°, and 25.16°) and moreover we could recognize a diffraction peak in the wide-angle region (24.9°), which might be interpreted as corresponding to the  $\pi$ - $\pi$  distance with a *d*-spacing of 3.57 Å (inset of Fig. 6b). The 2D-GIXD result for a 2H2TIDID-DCV thin film could further support our interpretation; we observed diffraction peaks corresponding to lamellar and  $\pi$ - $\pi$  d-spacings at values of  $q_z$  of 0.60 Å<sup>-1</sup> (10.47 Å) and  $q_{xy}$ of 1.76 Å<sup>-1</sup> (3.57 Å), respectively. Moreover, the 2D-GIXD patterns of an OD2TIDID-DCV spin-coated film also exhibited a similar result to that for 2H2TIDID-DCV, i.e., semiconductor molecules are oriented in exactly the same manner as that of 2H2TIDID-DCV VD film but with different values of the d-spacing (the values of the lamellar spacing and  $\pi$ - $\pi$  spacing are 17.9 Å and 3.64 Å, respectively). Via a comprehensive correlation between XRD, DFT calculations, and the results of AFM surface topography shown in Fig. 6, we could conclude that 2H2TIDID-DCV (and OD2TIDID-DCV) molecules are oriented on the substrate in an edge-on manner and their  $\pi$ -planes are stacked in a direction parallel to the surface. On the other hand, the van der Waals interactions of N-aliphatic chains enable 2H2TIDID-DCV and OD2TIDID-DCV to adopt a well-organized three-dimensional lamellar structure with lamellar spacings of 10.58 Å and 17.9 Å, respectively (see Fig. 6j).

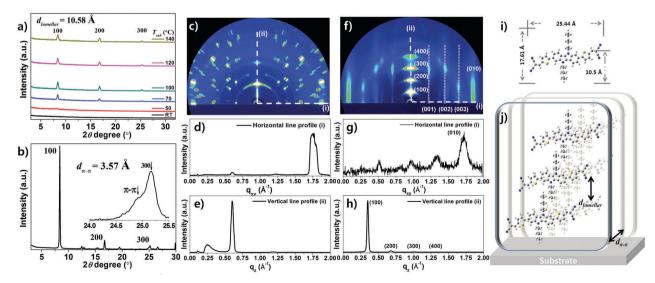


Fig. 6 (a) Out-of-plane XRD patterns of **2H2TIDID-DCV** VD films formed at different values of  $T_{sub}$ ; (b) powder XRD pattern of **2H2TIDID-DCV** powder; (c) 2D-GIXD diffraction pattern image of **2H2TIDID-DCV** VD film ( $T_{sub} = 140 \, ^{\circ}\text{C}$ ); (d and e) horizontal and vertical line profiles of (c), respectively; (f) 2D-GIXD diffraction pattern image of OD2TIDID-DCV film; (g and h) horizontal and vertical line profiles of (f), respectively; (i) calculated molecular size of 2H2TIDID-DCV; (j) schematic diagram of packing structure of 2H2TIDID-DCV.

We have designed and successfully synthesized  $A-\pi-D-\pi-A$ -type IDID-DCV derivatives with different  $\pi$ -spacers. It was found that compensated ICT interactions between IDID and DCV in 2TIDID-DCV derivatives (with a thiophene  $\pi$ -spacer) and their efficient electronic interactions in a three-dimensional lamellar  $\pi$ -stacking structure gave rise to a dramatically reduced energy band gap, as well as excellent film morphology. As a consequence, a VD OFET device using 2H2TIDID-DCV exhibited highly balanced ambipolar charge transport with hole and electron mobilities of 0.08 cm<sup>2</sup> V<sup>-1</sup> s<sup>-1</sup> and 0.09 cm<sup>2</sup> V<sup>-1</sup> s<sup>-1</sup>, respectively, and spin-coated OFET devices using OD2TIDID-DCV also exhibited ambipolar charge transport behavior (mobilities of  $9.67 \times 10^{-2} \ cm^2 \ V^{-1} \ s^{-1}$  for holes and  $3.43 \times 10^{-3} \ cm^2 \ V^{-1} \ s^{-1}$ for electrons).

### **Experimental section**

#### **Synthesis**

The final products were synthesized according to the synthetic procedure shown in Scheme 1. 2,7-Dibromo-5,10-dihexyl-5,10dihydroindolo[3,2-b]indole (2,7-dibromo-N,N'-dihexyl-IDID) was synthesized according to our previous report.<sup>25</sup> Unless stated otherwise, all reagents were purchased from Sigma Aldrich, TCI, and Alfa Aesar.

Synthesis of 5,10-dihexyl-5,10-dihydroindolo[3,2-b]indole-2,7-dicarbaldehyde (2). A 100 mL round-bottomed flask equipped with a magnetic stirrer bar was heated under reduced pressure and backfilled with Ar three times. A solution of compound 1 (200 mg, 0.375 mmol) in anhydrous tetrahydrofuran (THF) in the heated reaction vessel was cooled to -17 °C. Afterwards, n-butyllithium (n-BuLi, 1.6 M solution, 0.36 mL, 0.902 mmol) was added slowly. One hour later, dimethylformamide (DMF, 69 µL, 0.902 mmol) was added to the reaction mixture and then the reaction vessel was warmed to room temperature. After the reaction had finished, the reaction mixture was quenched with distilled water (200 mL) and the organic compounds were extracted with methylene chloride (DCM). The combined organic phase was separated and concentrated. The crude product was purified by column chromatography (ethyl acetate (EA)/n-hexane (n-hex.); 1:19, v/v) to afford compound 2 as a yellow solid (90 mg, 55.3%). <sup>1</sup>H NMR (300 MHz, CDCl<sub>3</sub>,  $\delta$ ): 10.14 (s, 2H), 8.04 (s, 2H), 7.98 (d, J =8.22 Hz, 2H), 7.74 (d, J = 8.19 Hz, 2H), 4.58 (t, J = 7.14 Hz, 4H), 2.00 (m, J = 7.41 Hz, 4H), 1.44-1.25 (m, 12H), 0.87 (t, J = 7.02 Hz, 6H).

Synthesis of 2HIDID-DCV. A mixed solution of compound 2 (200 mg, 0.462 mmol), malononitrile (67.9 mg, 1.017 mmol), Al<sub>2</sub>O<sub>3</sub> (377 mg, 3.698 mmol), and DCM (50 mL) was vigorously stirred for 2 hours at room temperature. After the reaction had finished, the reaction mixture was filtered through a Celite plug to remove residual Al<sub>2</sub>O<sub>3</sub> and the filtrate was concentrated under reduced pressure. The crude product was purified by flash column chromatography (THF) and subsequently by recrystallization (EA) to afford 2HIDID-DCV as a dark purple solid (220 mg, 90.3%). <sup>1</sup>H NMR (500 MHz, tetrahydrofuran- $d_8$ ,  $\delta$ ): 8.30 (s, 2H),

8.24 (s, 2H), 8.13 (d, I = 8.5 Hz, 2H), 7.86 (d, I = 8.5 Hz, 2H), 4.64 (t, J = 7.5 Hz, 4H), 2.00 (q, J = 7.5 Hz, 4H), 1.43 (q, J = 7.5 Hz, 4H),1.35–1.24 (m, 8H), 0.83 (t, J = 7.5 Hz, 6H). <sup>13</sup>C NMR (500 MHz, tetrahydrofuran- $d_8$ ,  $\delta$ ): 161.30, 142.50, 131.37, 127.80, 121.68, 120.41, 117.81, 115.66, 115.08, 115.04, 79.72, 46.40, 32.63, 31.28, 27.77, 23.54, 14.43. HRMS (FAB, m/z) calcd. for  $C_{34}H_{34}N_6$ : 526.28; found: 526.2851. Elem. anal. calcd. for C34H34N6: C 77.54, H 6.51, N 15.96; found: C 77.4905, H 6.5662, N 15.8965.

Synthesis of 5,10-dihexyl-2,7-bis(4,4,5,5-tetramethyl-1,3,2dioxaborolan-2-yl)-5,10-dihydroindolo[3,2-b]indole (3). A 100 mL round-bottomed flask equipped with a magnetic stirrer bar and a reflux condenser was heated under reduced pressure and backfilled with Ar three times. Compound 1 (1.00 g, 1.878 mmol), bis(pinacolato)diborane (1.06 g, 4.133 mmol), [1,1'-bis(diphenylphosphino)ferrocene]dichloropalladium(II) (345 mg, 0.413 mmol), potassium acetate (1.10 g, 11.271 mmol), and anhydrous DMF (35 mL) were added and then gently refluxed for 24 hours. After the reaction had finished, the reaction mixture was quenched with brine (300 mL) and extracted with DCM. The combined organic phase was dried with MgSO<sub>4</sub> and concentrated under reduced pressure. The crude product was purified by column chromatography (EA/n-hex.; 1:9, v/v) to afford compound 3 as a yellow solid (350 mg, 41%). <sup>1</sup>H NMR (300 MHz, CDCl<sub>3</sub>,  $\delta$ ): 7.93 (s, 2H), 7.84 (d, J = 7.86 Hz, 2H), 7.62 (d, J = 7.86 Hz, 2H), 4.55 (t, J = 6.93 Hz,4H), 1.98 (q, I = 6.57 Hz, 4H), 1.39 (s, 24H), 1.29 (m, 12H), 0.86 (t, J = 6.72 Hz, 6H).

Synthesis of 5,5'-(5,10-dihexyl-5,10-dihydroindolo[3,2-b]indole-2,7-diyl)bis(thiophene-2-carbaldehyde) (4). Compound 3 (205 mg, 0.223 mmol), 5-bromothiophene-2-carbaldehyde (131.3 mg, 0.469 mmol), tetrakis(triphenylphosphino)palladium(0) (37.38 mg, 0.032 mmol), a 2 N aqueous solution of K<sub>2</sub>CO<sub>3</sub> (10 mL), and THF (20 mL) were added to a 100 mL round-bottomed flask and the reaction vessel was evacuated and backfilled with Ar. After that, the reaction mixture was gently refluxed for 12 hours. After the reaction had finished, the reaction mixture was quenched with a 1 N aqueous solution of HCl (300 mL) and extracted with DCM. The combined organic phase was dried with MgSO<sub>4</sub> and concentrated under reduced pressure. The crude product was purified by flash column chromatography (EA/n-hex.; 1:2, v/v) and recrystallization (EA) to afford compound 4 as a red solid (190 mg, 94%). <sup>1</sup>H NMR (300 MHz, DMSO-d<sub>6</sub>,  $\delta$ ): 9.91 (s, 2H), 8.13 (s, 2H), 8.07 (d, J = 4.05 Hz, 2H), 8.00 (d, J = 8.37 Hz, 2H), 7.78 (d, J =3.96 Hz, 2H), 7.58 (d, J = 8.40 Hz, 2H), 4.68 (t, J = 6.48 Hz, 4H), 1.88 (q, J = 6.57 Hz, 4H), 1.23 (m, 12H), 0.81 (t, J = 6.57 Hz, 6H).

Synthesis of 2H2TIDID-DCV. 2H2TIDID-DCV was synthesized by the same synthetic procedure as that used for 2HIDID-DCV, using compound 4 (166 mg, 0.279 mmol), malononitrile (40.6 mg, 0.615 mmol), Al<sub>2</sub>O<sub>3</sub> (0.228 g, 2.535 mmol), and DCM (50 mL). The crude product was purified by flash column chromatography (THF) and subsequently by recrystallization (EA) to afford 2H2TIDID-DCV as a dark purple solid (0.189 g, 98%). <sup>1</sup>H NMR (500 MHz, tetrahydrofuran-d<sub>8</sub>,  $\delta$ ): 8.23 (s, 2H), 8.01 (d, J = 1.5 Hz, 2H), 7.98 (d, J = 8.5 Hz, 2H), 7.86 (d, J = 4 Hz, 2H), 7.73 (d, J = 4 Hz, 2H), 7.61 (dd, J = 8.5 Hz, 1.5 Hz, 2H), 4.66 (t, J = 7 Hz, 4H), 2.00 (q, J = 7.5 Hz, 4H), 1.45 (q, J = 7.5 Hz, 4H),1.38–1.25 (m, 8H), 0.85 (t, J = 7.5 Hz, 6H). <sup>13</sup>C NMR (500 MHz, tetrahydrofuran- $d_8$ ,  $\delta$ ): 158.93, 151.96, 142.73, 141.77, 125.19, 119.90, 118.46, 116.19, 115.45, 114.78, 109.18, 45.98, 32.70, 31.35, 27.73, 23.57, 14.46. HRMS (FAB, m/z) calcd. for C<sub>42</sub>H<sub>38</sub>N<sub>6</sub>S<sub>2</sub>: 690.26; found: 690.2563. Elem. anal. calcd. for C<sub>42</sub>H<sub>38</sub>N<sub>6</sub>S<sub>2</sub>: C 73.01, H 5.54, N 12.16, S 9.28; found: C 73.0165, H 5.5255, N 12.1216, S 9.2924.

Synthesis of 5',5'''-(5,10-dihexyl-5,10-dihydroindolo[3,2-b]indole-2,7-diyl)bis([2,2'-bithiophene]-5-carbaldehyde) (5). Compound 5 was synthesized by the same synthetic procedure as that used for compound 4, using compound 3 (170 mg, 0.271 mmol), 5'-bromo-[2,2'-bithiophene]-5-carbaldehyde (135 mg, 0.569 mmol), tetrakis(triphenylphosphino)palladium(0) (32 mg, 0.027 mmol), a 2 N aqueous solution of K<sub>2</sub>CO<sub>3</sub> (10 mL), and THF (20 mL). The crude product was purified by column chromatography (CHCl<sub>3</sub>/EA/n-hex.; 3:1:6, v/v) and subsequently by recrystallization (EA) to afford compound 5 as a red solid (162 mg, 78%). <sup>1</sup>H NMR (300 MHz, tetrahydrofuran-d<sub>8</sub>,  $\delta$ ): 9.83 (s, 2H), 7.90 (d, J = 8.28 Hz, 2H), 7.83 (s, 2H), 7.79 (d, J = 3.9 Hz, 2H), 7.48-7.46 (m, 6H), 7.39 (d, J = 3.9 Hz, 2H), 4.61 (t, J = 6.9 Hz, 4H), 1.98 (q, J = 7.47 Hz, 4H), 1.46-1.25 (m, 12H), 0.49 (t, J =7.08 Hz, 6H).

Synthesis of 2H4TIDID-DCV. 2H4TIDID-DCV was synthesized by the same synthetic procedure as that used for 2HIDID-DCV, using compound 5 (162 mg, 0.213 mmol), malononitrile (43 mg, 0.640 mmol), Al<sub>2</sub>O<sub>3</sub> (0.228 g, 1.921 mmol), and DCM (60 mL). The crude product was purified by flash column chromatography (THF) and subsequently by recrystallization (THF) to afford 2H4TIDID-DCV as a black solid (0.110 g, 60%). <sup>1</sup>H NMR (500 MHz, tetrahydrofuran-d<sub>8</sub>,  $\delta$ ): 8.14 (s, 2H), 7.90 (d, J = 8.5 Hz, 2H), 7.84 (s, 2H), 7.78 (d, J = 4 Hz, 2H), 7.56(d, J = 3.5 Hz, 2H), 7.49 (m, 4H), 7.44 (d, J = 4 Hz, 2H), 4.61 (t, J = 4 Hz7 Hz, 4H), 2.03 (m, 4H), 1.48 (q, J = 7 Hz, 4H), 1.39-1.27 (m, 8H), 0.85 (t, J = 7 Hz, 6H). HRMS (FAB, m/z) calcd. for  $C_{50}H_{42}N_6S_4$ : 854.24; found: 854.2363. Elem. anal. calcd. for C<sub>50</sub>H<sub>42</sub>N<sub>6</sub>S<sub>4</sub>: C 70.23, H 4.95, N 9.83, S 15.0; found: C 69.8566, H 5.0406, N 9.8086, S 15.0143. (We could not obtain <sup>13</sup>C NMR data owing to the insufficient solubility of 2H4TIDID-DCV in common NMR solvents such as CDCl<sub>3</sub> or tetrahydrofuran-d<sub>8</sub>.)

#### Characterization

The chemical structures of the newly synthesized materials were fully identified by <sup>1</sup>H NMR, <sup>13</sup>C NMR (Bruker Advance 300 and Advance 500), GC-MS (JEOL, JMS-700) and elemental analysis (CE Instruments EA1110). UV-vis spectra were recorded on a Shimadzu UV-1650PC. The HOMO and LUMO energy levels of the organic materials were determined from cyclic voltammetry (CV) measurements. CV measurements were performed using a 273A (Princeton Applied Research) with a onecompartment platinum working electrode, a platinum wire counter electrode, and a quasi-Ag<sup>+</sup>/Ag electrode as a reference electrode. The measurements were performed in a 0.5 mM solution in tetrahydrofuran with 0.1 M tetrabutylammonium tetrafluoroborate

(TBATFB) as a supporting electrolyte and acetonitrile with 0.1 M TBATFB for the films as a supporting electrolyte at a scan rate of 50 mV s<sup>-1</sup>. Each oxidation and reduction potential was calibrated using ferrocene as a reference. The film surface topologies were determined with a Bruker Nanoscope III Multimode SPM in tapping mode using a RTESP cantilever. Out-ofplane X-ray diffraction and powder X-ray diffraction measurements were performed using a Bruker D8 Advance X-ray diffractometer. Two-dimensional grazing incidence X-ray diffraction measurements were performed at the 3C beamline of Pohang Acceleration Laboratory. Density functional theory (DFT) calculations were performed by the B3LYP method using the Gaussian 09 package with the 6-31G(d,p) basis set. The I-Vcharacteristics of all devices were measured using a Keithley 4200 SCS analyzer.

# OFET device fabrication and measurement

To prepare the substrates, SiO<sub>2</sub>/Si substrates (p-doped, 300 nm) were rinsed with acetone and isopropyl alcohol sequentially for 10 minutes in an ultrasonicator, followed by treatment for 15 minutes with UV (360 nm) and O<sub>3</sub>. For the fabrication of thermally evaporated vacuum-deposited OFET devices, octadecyltrichlorosilane (ODTS) was treated as a self-assembled monolayer (SAM) on the prepared substrate to reduce the number of charge trap sites as well as to enlarge domains. ODTS was treated in the vapor phase in a vacuum oven and then the substrates were passed into a nitrogen-filled glove box. Organic semiconductor active layers with a thickness of 30 nm were thermally deposited at a deposition rate of 0.1-0.2 Å s<sup>-1</sup> and different substrate temperatures ( $T_{\text{sub}}$ : room temperature, 50, 70, 100, 120, and 140 °C) under a vacuum of  $7 \times 10^{-7}$  Torr. As the source and drain electrodes, gold (Au) with a thickness of 50 nm was thermally deposited at a deposition rate of  $0.2-0.3 \text{ Å s}^{-1}$ . For the fabrication of spin-coated OFET devices, the same procedure for substrate preparation was performed as with the VD devices. OD2TIDID-DCV was dissolved in chloroform (0.3-0.4 weight%) and spin-coated at 1500-3000 rpm for 1 minute in a nitrogen-filled glove box and then the substrates were annealed at different temperatures from room temperature to 150 °C. The source and drain electrodes were thermally deposited under the same conditions as were used for the fabrication of VD devices. The I-V characteristics of all the OFETs were measured in a nitrogenfilled glove box using a Keithley 4200 SCS instrument connected to a probe station. All the OFET characteristics were determined from the transfer curve in the saturation regime. For the calculations of charge carrier mobility, we measured the channel width and length of the individual devices using an optical microscope.

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#### References

- 1 J. G. Champlain, Appl. Phys. Lett., 2011, 99, 123502.
- 2 J. Zaumseil and H. Sirringhaus, Chem. Rev., 2007, 107, 1296.
- 3 S.-I. Noro, T. Takenobu, Y. Iwasa, H.-C. Chang, S. Kitagawa, T. Akutagawa and T. Nakamura, *Adv. Mater.*, 2008, **20**, 3399.
- 4 T. D. Anthopoulos, S. Setayesh, E. Smits, M. Cölle, E. Cantatore, B. Bore, P. W. M. Blom and D. M. Leeuw, *Adv. Mater.*, 2006, **18**, 1900.
- 5 K. Liu, C.-L. Song, Y.-C. Zhou, X.-Y. Zhou, X.-J. Pan, L.-Y. Cao, C. Zhang, Y. Liu, X. Gong and H.-L. Zhang, J. Mater. Chem. C, 2015, 3, 4188.
- 6 J. Bardeen, Phys. Rev., 1947, 71, 717.
- 7 T. Kanagasekaran, H. Shimotani, S. Ikeda, H. Shang, R. Kumashiro and K. Tanigake, *Appl. Phys. Lett.*, 2015, **107**, 043304.
- 8 E. J. Meijer, D. M. D. Leeuw, S. Setayesh, E. V. Veenendaal, B.-H. Huisman, P. W. M. Blom, J. C. Hummelen, U. Scherf and T. M. Klapwijk, *Nat. Mater.*, 2003, 2, 678.
- 9 B. Jaeckel, J. B. Sambur and B. A. Parkinson, *Appl. Phys. Lett.*, 2008, **103**, 063719.
- 10 T. Yasuda, T. Goto, K. Fujita. and T. Tsutsui, *Appl. Phys. Lett.*, 2004, **85**, 2098.
- 11 J.-Y. Hu, M. Nakano, I. Osaka and K. Takimiya, *J. Mater. Chem. C*, 2015, 3, 4244.
- 12 M. L. Tang, A. D. Reichardt, N. Miyaki, R. M. Stoltenberg and Z. Bao, *J. Am. Chem. Soc.*, 2008, **130**, 6064.
- 13 Y.-Y. Liu, C.-L. Song, W.-J. Zeng, K.-G. Zhou, Z.-F. Shi, C.-B. Ma, F. Yang, H.-L. Zhang and X. Gong, *J. Am. Chem. Soc.*, 2010, 132, 16349.
- 14 C.-L. Song, C.-B. Ma, F. Yang, W.-J. Zeng, H.-L. Zhang and X. Gong, *Org. Lett.*, 2011, **13**, 2880.
- 15 J. Lee, A.-R. Han, H. Yu, T. J. Shin, C. Yang and J. H. Oh, *J. Am. Chem. Soc.*, 2013, **135**, 9540.
- 16 B. Sun, W. Hong, Z. Yan, H. Aziz and Y. Li, *Adv. Mater.*, 2014, **26**, 2636.

- 17 L. Wang, X. Zhang, H. Tian, Y. Lu, Y. Geng and F. Wang, Chem. Commun., 2013, 49, 11272.
- 18 A. Riaño, P. M. Burrezo, M. J. Mancheño, A. Timalsina, J. Smith, A. Facchetti, T. J. Marks, H. T. L. Navarrete, J. L. Segura, J. Casado and R. P. Ortiz, J. Mater. Chem. C, 2014, 2, 6376.
- M. Irimia-Vladu, E. D. Głowacki, P. A. Troshin,
   G. Schwabegger, L. Leonat, D. K. Susarova, O. Krystal,
   M. Ullah, Y. Kanbur, M. A. Bodea, V. F. Razumov,
   H. Sitter, S. Bauer and N. S. Sariciftci, Adv. Mater., 2012,
   24, 375.
- 20 I. Meager, M. Nikolka, B. C. Schroeder, C. B. Nielsen, M. Planells, H. Bronstein, J. W. Rumer, D. I. James, R. S. Ashraf, A. Sadhanala, P. Hayoz, J.-C. Flores, H. Sirringhaus and I. McCulloch, Adv. Funct. Mater., 2014, 24, 7109.
- 21 J. C. Ribierre, L. Zhao, S. Furukawa, T. Kikitsu, D. Inoue, A. Muranaka, K. Takaishi, T. Muto, S. Matsumoto, D. Hashizume, M. Uchiyama, P. André, C. Adachi and T. Aoyama, *Chem. Commun.*, 2015, 51, 5836.
- 22 J. Li, X. Qiao, Y. Xiong, H. Li and D. Zhu, *Chem. Mater.*, 2014, 26, 5782.
- 23 J. C. Ribierre, S. Watanabe, M. Matsumoto, T. Muto, D. Hashizume and T. Aoyama, *J. Phys. Chem. C*, 2011, 115, 20703.
- 24 K. Zhou, H. Dong, H.-L. Zhang and W. Hu, *Phys. Chem. Chem. Phys.*, 2014, **16**, 22448.
- 25 I. Cho, S. K. Park, B. Kang, J. W. Chung, J. H. Kim, K. Cho and S. Y. Park, Adv. Funct. Mater., 2016, 26, 2966.
- 26 T. Qi, Y. Liu, W. Qiu, H. Zhang, X. Gao, Y. Liu, K. Lu, C. Du, G. Yu and D. Zhu, J. Mater. Chem., 2008, 18, 1131.
- 27 X. Lu, S. Fan, J. Wu, X. Jia, Z.-S. Wang and G. Zhou, *J. Org. Chem.*, 2014, **79**, 6480.
- 28 H. Dong, X. Fu, J. Liu, Z. Wang and W. Hu, *Adv. Mater.*, 2013, 25, 6158.